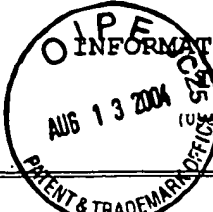
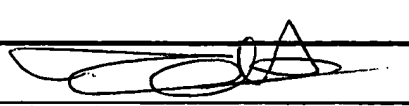


Form PTO-1449 <div style="text-align: center;">  <p>INFORMATION DISCLOSURE CITATION IN AN APPLICATION <small>(Use several sheets if necessary)</small></p> </div>		ATTY. DOCKET NO. 4392-0155P		APPLICATION NO. 10/800,695	
APPLICANT CHEN, Yi-Nan et al.		FILING DATE March 16, 2004		GROUP 2813	

U.S. PATENT DOCUMENTS							
EXAMINER INITIAL	DOCUMENT NUMBER	Kind	DATE	NAME	CLASS	SUB CLASS	FILING DATE IF APPROPRIATE
	US						
	US						
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FOREIGN PATENT DOCUMENTS								
Office	DOCUMENT NUMBER	Kind	DATE	COUNTRY	CLASS	SUB CLASS	TRANSLATION	
							YES	NO

OTHER DOCUMENTS	
(Include Name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.) date, page(s), volume-issue number(s), publisher, city and/or country where published.	
TSP	"VLSI Manufacturing Technology," ISBN 957-584-327-4, July 10, 1997, pp. 402, 454 and 461, with English language translation.

EXAMINER 	DATE CONSIDERED 11/5/04
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EXAMINER: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.